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INFORMATION DISCLOSURE				Application Number	10/574,015	
				Filing Date	March 29, 2006	
STATEMENT BY APPLICANT		First Named Inventor	Hiromi AKIYOSHI et al.			
	(use as many sheets as necessary)		Group Art Unit	3663		
				Examiner Name	Redhwan K. Mawari	
Sheet	1	of	1	Attorney Docket Number	0670-7073	

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